

PERFORMANCE, QUALITY, VALUE

SICHATORE®

# WL-210 RF / Microwave Probe Station

SIGNATONE analytical probe stations are recognized as the performance / value leaders in the microprobing market. The WAVELINK Series extends this expertise into the RF & MW segment, historically dominated by more expensive alternatives.

While this has long been held to be the realm of voodoo, the occult, and black magic, this is no longer the case. Any modern probe station precise enough to contact a sub-micron line is certainly stable enough to hit a  $100\mu$  pad with a  $50\mu$  RF probe. In the past decade network analyzers have gotten more stable, accurate, and easy to use. Shouldn't your probe station?

Building on the proven CheckMate architecture, and in consultations with our installed base of RF technologists, SIGNATONE has incorporated many features into the WAVELINK Series unique to the world of VNA's and coplanar probes.

Take another look at SIGNATONE – Perhaps for the first time. We listened, and we think you'll like what you see.



The WL-210 calibration chuck offers 3 substrate sites which support either landscape or portrait format calibration substrates.



The tilt-back microscope provides unobstructed fixturing access.

### Common Features

Massive 2" one-piece machined aircraft aluminum base for stability

Large Heavy-duty nickel steel platen with 4-point support and lift

Compound coarse/fine X-Y stage drive for fast, precise positioning

Separate calibration chuck eliminates the error-inducing step of removing the wafer under test and substituting the substrate in it's place for calibration

Accepts shards through 8" wafers, substrates, PCB's, and thinned wafers

Independent platen height (locking) and contact/separate controls

Non-ferrous chuck and stage reduces ferromagnetic resonance and crosstalk

Supports bolt-down, vacuum, and magnetic base micropositioners

Banana, BNC, and Triax chuck bias connections

Quick-Change probe card holder option with independent  $\Theta$  adjustment

In-The Field upgrade options for motion control, local enclosure and thermal configurations

# Specifications

### X-Y Stage

Travel: 200mm X 200mm Bearings: Carriage & Rails Stage Drive: Coarse/Fine Coaxial Resolution: 5 mm/turn, .5 mm/turn

# Wafer Chuck

Size: 200 mm

Metallurgy: Nickel/Gold plated Aluminum Vacuum: Shard, 100mm, 150mm 200mm Isolation: > 100 M $\Omega$ , > 600V breakdown Bias Input: Triax, BNC, Banana Flatness:  $\pm$  6  $\mu$ m across chuck Theta:  $\pm$  10°, independent of cal chuck

Z: .025" pneumatic actuation

## Platen

Adjustment Range: 2", locking Contact/Separate: .125" Lift: 4-point, planar

Metallurgy: .625" Nickel-plated steel

Positioner Support: Bolt down, Magnetic, Vacuum

### Microscope Transport

Low-Power: 4" X 4", 20 TPI, manual tilt-back High-Power (Optional): 2" X 2", 40 TPI, 4" vertical lift

### Calibration Chuck

# Sites: 3

Orientation: Landscape or portrait

Facilities/Mechanical

Dimensions: 55 (21.6") X 66 (26.0") X 78.5 (30.9")

Net Weight: 91 kg (200 lb.) Shipping Weight: 150 kg (325 lb.)

Air: > 2 cfm, 30 psi

Vacuum: > 400 mm/15 in. Hg

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